



**PATENT APPLICATION**

*PPD  
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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:

Confirmation No.: 2221

LEE et al.

Art Unit: 1753

Application No.: 10/658,460

Examiner: S. Versteeg

Filed: September 10, 2003

Docket No.: 101136-00095

For: BIAS SPUTTERING FILM FORMING PROCESS AND BIAS SPUTTERING FILM FORMING APPARATUS

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

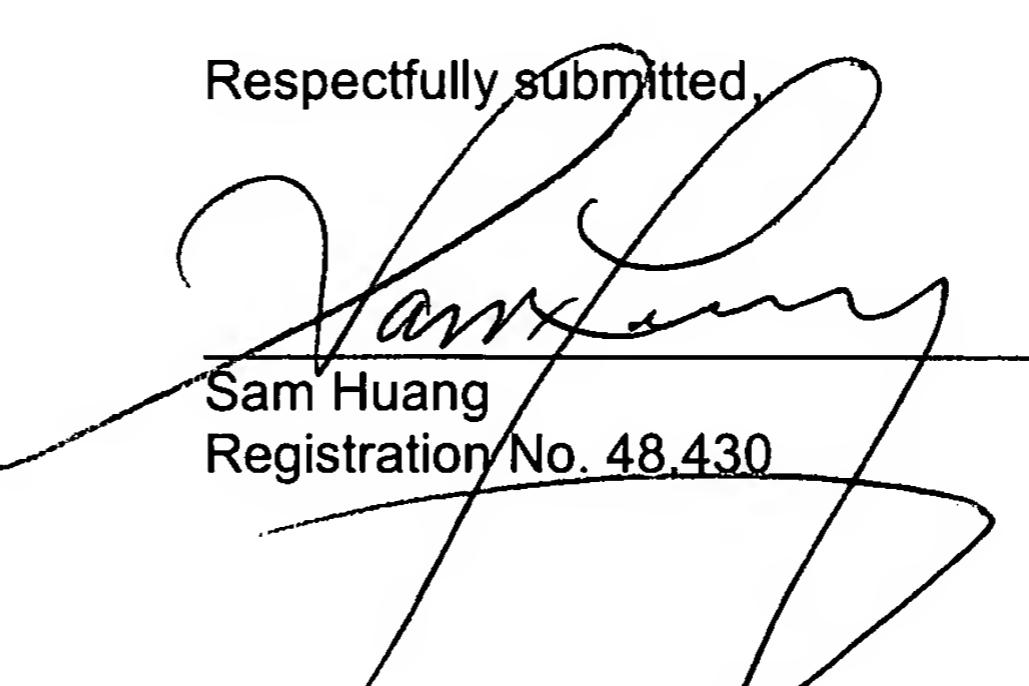
August 31, 2005

Sir:

Applicants petition for an extension of time for one month for response to the outstanding Office Action dated May 2, 2005 from August 2, 2005 to September 2, 2005.

Please find attached a check in the amount of One Hundred Twenty Dollars (\$120.00) to cover the fee discussed above. The Commissioner is hereby authorized to charge any fee deficiency or credit any overpayment associated with this communication to Deposit Account No. 01-2300, referring to client-matter number 101136-00095.

Respectfully submitted,

  
Sam Huang  
Registration No. 48,430

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